

Title (en)

PROCESS FOR PRODUCING A DISH CAPACITOR.

Title (de)

HERSTELLUNGSVERFAHREN FÜR EINEN SCHÜSSELKONDENSATOR.

Title (fr)

PROCEDE DE FABRICATION D'UN CONDENSATEUR EN CUVETTE.

Publication

**EP 0647356 A1 19950412 (DE)**

Application

**EP 93912618 A 19930624**

Priority

- DE 9300551 W 19930624
- DE 4221431 A 19920630

Abstract (en)

[origin: WO9400874A1] According to the invention, in a dish capacitor, especially for use in stacked capacitor above bit line storage cells, a chemical mechanical polishing (CMP) process is used in producing the lower capacitor electrode (44, 46).

IPC 1-7

**H01L 21/82**; **H01L 27/108**

IPC 8 full level

**H01L 21/8242** (2006.01); **H01L 21/02** (2006.01); **H01L 21/822** (2006.01); **H01L 27/04** (2006.01); **H01L 27/108** (2006.01)

CPC (source: EP KR)

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Citation (search report)

See references of WO 9400874A1

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